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By:

LINDA E. HASTINGS

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Attorney Docket No.: NECW 18.281 (100806-17349)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Toru TATSUMI et al.

Serial No.: 09/744,701

Filed: January 29, 2001

Title: **METHOD OF VAPOR PHASE GROWTH OF METAL OXIDE  
DIELECTRIC FILM AND APPARATUS FOR VAPOR PHASE  
GROWTH OF METAL DIELECTRIC MATERIAL**

Examiner: H. Jey Tsai

Group Art Unit: 2812

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**ELECTION**

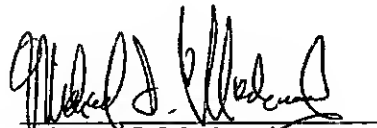
SIR:

In response to the Office Action mailed on December 8, 2003, the period for responding thereto having been set to expire after January 8, 2004, Applicant hereby elects the first species of using a vacuum apparatus having more than one gas inlet, claims 47-56 and 118-121 being in the first species, for prosecution at this time. Applicant reserves the right to file continuing application(s) based on the second species of forming a crystalline perovskite type material,

claims 61-90 being in the second species. The identification of the claims in each of the two species was agreed to by the Examiner in telephone conversations on December 18, 2003. Early examination on the merits is earnestly solicited.

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Respectfully submitted,

  
\_\_\_\_\_  
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